

[illegible]

| EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | COUNTRY | CLASS/ SUBCLASS | TRANSLATION YES | NO |
|---------------------|----|--------------------|---------|---------|--------------------|--------------------|----|
| RST | B1 | 3-132910 | 06/1991 | Japan | | X | |
| | B2 | 4-195801 | 07/1992 | Japan | | X | |
| | B3 | 2000-123322 | 04/2000 | Japan | | X | |
| | B4 | 11-191206 | 07/1999 | Japan | | X | |
| RST | B5 | 9-167317 | 06/1997 | Japan | | X | |

| EXAMINER INITIAL | OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.) | |
|---------------------|--|--|
| RST | B6 | Copy of Office Action dated October 29, 2004 for Japanese Patent Application No. 2001-036499 |
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| EXAMINER | R.S. Tupper | DATE CONSIDERED | 2/05 |
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